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Rih Data Sheet

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chiura, JAPAN;				
iura, JAPAN;	Oume, JAPAN;			
DIV of 09/890,611 10/11/200 T/JP99/01319 03/17/1999	1 PAT 6,656,752 A	+		
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52	COUNTRY	SHEETS DRAWING 4	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 3
JT & KRAUS, LLP TH STREET			·	·
g method and instrument, and	d semiconductor device ma	nufacturing method		
Authority has been given in F to charge/credit DEF for following:	All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other			
	RULE Chiura, JAPAN; iura, JAPAN; iura, JAPAN; uchiura, JAPAN; Kodaira, JAPAN; atsu, JAPAN; DIV of 09/890,611 10/11/200 T/JP99/01319 03/17/1999 S LING LICENSE GRANTED yes no Met after Alla miner's Signature Init JT & KRAUS, LLP TH STREET Authority has been given in F to charge/credit DEF	RULE Chiura, JAPAN; iura, JAPAN; uchiura, JAPAN; uchiura, JAPAN; Kodaira, JAPAN; Kodaira, JAPAN; atsu, JAPAN; atsu, JAPAN; DIV of 09/890,611 10/11/2001 PAT 6,656,752 T/JP99/01319 03/17/1999 S LING LICENSE GRANTED STATE OR COUNTRY JAPAN JAPAN JT & KRAUS, LLP TH STREET Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT	RULE Chiura, JAPAN; Alaman JA	RULE Chiura, JAPAN; iura, JAPAN; iura, JAPAN; iura, JAPAN; iura, JAPAN; iura, JAPAN; Kodaira, JAPAN; atsu, JAPAN; ELING LICENSE GRANTED COUNTRY JAPAN STATE OR JAPAN STATE OR JAPAN COUNTRY JAPAN TE & KRAUS, LLP TH STREET G method and instrument, and semiconductor device manufacturing method Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT for following: Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT for following: 1.18 Fees (Issue)